FLOW DIAGNOSTIC SYSTEM

CROSS-REFERENCE TO RELATED APPLICATIONS

This is a Continuation-In-Part of U.S. application Serial No. 09/257,896, filed February 25, 1999 Which is a Continuation-In-Part of U.S. application Serial No. 08/623,569, filed March 28, 1996, and this application is also a Continuation-In-Part of U.S. application Serial No. 09/383,828, filed August 27, 1999, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1997, 1999, 1999, 1997, 1999, 1997, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999, 1999,

FIELD OF THE INVENTION

The present invention relates to fluid process control systems. In particular, the present invention relates to diagnostic systems for fluid flow in process control systems.

BACKGROUND OF THE INVENTION

20 Fluid flow meters are used in industrial process control environments to measure fluid flow and provide flow signals for flow indicators and controllers. Inferential flow meters measure fluid flow in a pipe by measuring a pressure drop near a discontinuity within the pipe. The discontinuity (primary element) 25 can be an orifice, a nozzle, a venturi, a pitot tube, a vortex shedding bar, a target or even a simple bend in the pipe. Flow around the discontinuity causes both a pressure drop and increased turbulence. The pressure drop is sensed by a pressure transmitter (secondary 30 element) placed outside the pipe and connected by impulse lines or impulse passageways to the fluid in the pipe. Reliability depends on maintaining a correct